Editor's Comment:

I carefully reviewed the revised manuscript entitled "Diffusion and trapping of positrons in unimplanted and ion-implanted 3C-SiC and 6H-SiC" and the reviewers comments, when I go through the reviewers comments and author reply, I noticed some improvement in the revised manuscript and all of the reviewers already given high marks to the manuscript, From editorial point of view, the final decision of this manuscript is accept.

Editor's Details:

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